

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Paul A. Farrar

Title: METHOD OF CLEANING SEMICONDUCTOR SURFACES

Docket No.:	1303.112US1	Serial No.:	10/681,481
Filed:	October 8, 2003	Due Date:	June 12, 2008
Examiner:	Joy Watson	Group Art Unit:	1792
		Confirmation No.:	7468

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

We are transmitting herewith the following attached items (as indicated with an "X"):

- Amendment and Response under 1.111 (8 pgs.)
- Petition for Extension of Time (1 pg.)
- Authorization to charge Deposit Account 19-0743 in the amount of \$120.00 to cover the Extension of Time Fee.

If not provided for in a separate paper filed herewith, please consider this a PETITION FOR EXTENSION OF TIME for sufficient number of months to enter these papers and please charge any additional fees or credit overpayment to Deposit Account No. 19-0743.

SCHWEGMAN, LUNDBERG & WOESSNER, P.A.

By: 

David C. Peterson
Reg. No. 47,857

CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being filed using the USPTO's electronic filing system EFS-Web, and is addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on this 12 day of June, 2008.

Name

Leslie Wolfe

Ludue Woyce
Signature